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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Hiroyuki Ikeda **Atty. Docket No.** 075834.00064
Serial No.: 09/ 821,636 **Group Art Unit:** 2811
Filed: March 29, 2001 **Examiner:** Thien F. Tran
Invention: "THIN FILM SEMICONDUCTOR APPARATUS AND
METHOD FOR DERIVING THE SAME"

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Jwm.

RESPONSE TO ELECTION/RESTRICTION REQUIREMENT

Assistant Commissioner of Patents
Washington, D.C. 20231

S I R:

In response to the Office Action dated June 7, 2002, Applicant elects claims 1-19 of Invention I drawn to a semiconductor device and Embodiment 1 of Fig. 1, drawn to a thin film semiconductor device. Applicant specifically reserves the right to prosecute the non-elected claims in a later filed continuation or divisional application.

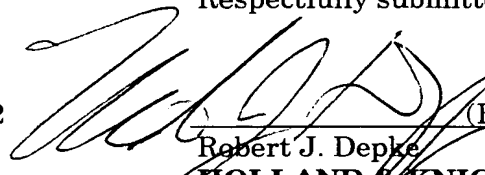
Applicant therefore awaits consideration and examination of elected claims 1-19 and respectfully requests consideration on the merits in due course.

NEW ATTORNEY OF RECORD

Applicant has concurrently submitted herewith a Revocation and Substitute Power of Attorney document that has been executed and requests that all future correspondence be directed to the attention of the undersigned.

Respectfully submitted,

Date: July 8, 2002


(Reg. #37,607)
Robert J. Depke
HOLLAND & KNIGHT LLP
55 West Monroe Street, Suite 800
Chicago, Illinois 60603
Tel: (312) 422-9050
Attorney for Applicant

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Attorney for Applicant

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